



-- The subject matter of the present divisional reissue application is related to co-pending divisional reissue application entitled Inspecting Optical Masks With Electron Beam Microscopy, said application having Serial No. 09/502,534, which reissue divisional application was also filed on February 10, 2000. ~

REMARKS

The amendments to the specification indicate the the subject matter of the present application is related to a co-pending divisional reissue application. Applicants respectfully request the Examiner to issue an early notice of allowance for this application.

Respectfully submitted,
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